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Applicant

Yi-Ming Sheu et al.

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U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
W/B	6162679	12/19/00	Lin	438	253	5/6/99
W/B	5960276	9/28/99	Liauw et al.	438	224	9/28/98
W/B	6228726	5/8/01	Liauw	438	294	3/6/00
W/B	5296392	3/22/94	Gruha et al.	437	34	2/24/92
W/B	6277697	8/21/01	Lee	438	296	11/12/99
W/B	6245639	6/12/01	Tsai et al.	438	424	2/8/99
W/B	6331458	12/18/01	Anjum et al.	438	197	9/22/95
W/B	6504219	1/7/03	Puchner et al.	257	371	9/21/01

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
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